Docket No.

219723US2S

IN RE APPLICATION OF: Hajime NAGANO et al.

SERIAL NO: 10/078,344

ALLOWED:

September 3, 2004

FILED:

February 21, 2002

FOR:

SEMICONDUCTOR DEVICE USING PARTIAL SOI SUBSTRATE AND MANUFACTURING METHOD

**THEREOF** 

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

Transmitted herewith is an amendment under 37 C.F.R. § 1.312 in the above-identified application.

- No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	8	MINUS	25	0	x \$18 =	\$0.00
INDEPENDENT	1	MINUS	3	0	x \$88 =	\$0.00
		☐ MULTIPLE DEPENDENT CLAIMS + \$300 =				\$0.00
		TOTAL OF ABOVE CALCULATIONS \$0.00				
		☐ Reduction by 50% for filing by Small Entity \$0.00				
		☐ Recordation of Assignment + \$40 =				\$0.00
					TOTAL	\$0.00

☐ A check in the amount of	f <b>\$0.00</b> is	attached
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- ☐ Credit card payment form is attached to cover the fees in the amount of \$0.00
- Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Customer Number

Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 05/03)

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Eckhard H. Kuesters

Registration No. 28,870



DOCKET NO: 219723US2S

## IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

:

HAJIME NAGANO ET AL.

: EXAMINER: NGO, N. V.

SERIAL NO: 10/078,344

.

FILED: FEBRUARY 21, 2002

: GROUP ART UNIT: 2814

FOR: SEMICONDUCTOR DEVICE

: ALLOWED: SEPTEMBER 3, 2004

USING PARTIAL SOI SUBSTRATE

AND MANUFACTURING METHOD THEREOF

## AMENDMENT UNDER 37 C.F.R. § 1.312

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Notice of Allowance dated September 3, 2004, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.